

Application No.: 10/654,376

Docket No.: LLOYDW 3.0-011

IN THE SPECIFICATION

On page 5, lines 18-19, please correct the following sentence as shown:

The CO-based etching recipe can be a mixture of CO, Cl<sub>2</sub>, N<sub>2</sub>~~7~~  
and O<sub>2</sub> or CO<sub>2</sub> and NH<sub>3</sub>, for example.